| | Type | Hits | Search Text | DBs | Time Stamp |
|---|---|---|---|---|---|
| 1 | BRS | 2 | "6653206".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 15:27 |
| 2 | BRS | 524 | 438/977.ccls. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 15:27 |
| 3 | BRS | 844 | 438/455.ccls. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 15:28 |
| 4 | BRS | 549 | 438/458.ccls. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 15:28 |
| 5 | BRS | 2 | "6376332".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 15:28 |
| 6 | BRS | 10 | ("5371037" "5856229" "5869386" "6214701" "5811348").pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 15:36 |
| 7 | BRS | 2 | "20020096717" | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 15:39 |
| 8 | BRS | 2 | jp-05021338-$.did. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 15:39 |
| 9 | BRS | 2 | jp-07302889-$.did. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 15:40 |
| 10 | BRS | 4 | ("5869386" \| "6140209" \| "6143628" \| "6190937").PN. | US-PGPUB; USPAT; USOCR | 2004/11/19 15:48 |
| 11 | BRS | 0 | ("5869386" \| "6140209" \| "6143628" \| "6190937").PN. and detect$3 | US-PGPUB; USPAT; USOCR | 2004/11/19 15:50 |
| 12 | BRS | 4 | ("6376332").URPN. | USPAT | 2004/11/19 15:48 |
| 13 | BRS | 0 | ("5869386" \| "6140209" \| "6143628" \| "6190937").PN. and shift$3 | US-PGPUB; USPAT; USOCR | 2004/11/19 15:50 |

| | Type | Hits | Search Text | DBs | Time Stamp |
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| 14 | BRS | 21576 | first adj substrate same second adj substrate | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 16:01 |
| 15 | BRS | 368 | first adj substrate same second adj substrate same porous | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 16:06 |
| 16 | BRS | 92 | first adj substrate same second adj substrate same porous and detect$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 16:01 |
| 17 | BRS | 26 | first adj substrate same second adj substrate same porous and detect$3 and image | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 16:04 |
| 18 | BRS | 8 | first adj substrate same second adj substrate same porous and detect$3 and image adj sens$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 16:06 |
| 19 | BRS | 199 | first adj substrate same second adj substrate same porous and apparatus | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 16:09 |
| 20 | BRS | 10 | first adj substrate same second adj substrate same porous and detect$3 and image near2 sens$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 16:07 |
| 21 | BRS | 24 | first adj substrate same second adj substrate same porous and apparatus same image | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 16:14 |
| 22 | BRS | 9 | first adj substrate same second adj substrate same porous and camera | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2004/11/19 16:14 |
| 23 | BRS | 7 | ("20020096717" \| "5371037" \| "5811348" \| "5856229" \| "5869386" \| "6214701" \| "6376332").PN. | US-PGPUB; USPAT; USOCR | 2004/11/20 13:39 |
| 24 | BRS | 45 | detection adj apparatus and first adj substrate same second adj substrate | US-PGPUB; USPAT; USOCR | 2004/11/20 13:48 |
| 25 | BRS | 8 | detection adj apparatus and first adj substrate same second adj substrate and determination and arrangement | US-PGPUB; USPAT; USOCR | 2004/11/20 13:51 |

| | Type | Hits | Search Text | DBs | Time Stamp |
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| 27 | BRS | 155 | 216/95.ccls. | US-PGPUB; USPAT; USOCR | 2004/11/20 13:51 |
| 28 | BRS | 1952 | 257/347.ccls. | US-PGPUB; USPAT; USOCR | 2004/11/20 13:51 |
| 29 | BRS | 411 | 257/466.ccls. | US-PGPUB; USPAT; USOCR | 2004/11/20 13:51 |
| 30 | BRS | 88 | 117/58.ccls. | US-PGPUB; USPAT; USOCR | 2004/11/20 13:51 |
| 31 | BRS | 194 | 117/94.ccls. | US-PGPUB; USPAT; USOCR | 2004/11/20 13:51 |

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| **26** | BRS | 767 | 216/20.ccls. | US-PGPUB; USPAT; USOCR | 2004/11/20 13:51 |

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# Inventor Name Search Result

Your Search was:

Last Name = YANAGITA
First Name = KAZUTAKA

| Application# | Patent# | Status | Date Filed | Title | Inventor Name 51 |
|---|---|---|---|---|---|
| 10963483 | Not Issued | 020 | 10/12/2004 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | YANAGITA, KAZUTAKA |
| 10944864 | Not Issued | 020 | 09/21/2004 | METHOD AND APPARATUS FOR SEPARATING MEMBER | YANAGITA, KAZUTAKA |
| 10834932 | Not Issued | 030 | 04/30/2004 | SEPARATING APPARATUS AND PROCESSING METHOD FOR PLATE MEMBER | YANAGITA, KAZUTAKA |
| 10792695 | Not Issued | 041 | 03/05/2004 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | YANAGITA, KAZUTAKA |
| 10787195 | Not Issued | 030 | 02/27/2004 | BONDING SYSTEM AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | YANAGITA, KAZUTAKA |
| 10754531 | Not Issued | 030 | 01/12/2004 | ETCHING METHOD | YANAGITA, KAZUTAKA |
| 10736519 | Not Issued | 030 | 12/17/2003 | PROCESSING APPARATUS | YANAGITA, KAZUTAKA |
| 10733361 | Not Issued | 030 | 12/12/2003 | PROCESSING APPARATUS FOR PROCESSING SUBSTRATE BY PROCESS SOLUTION | YANAGITA, KAZUTAKA |
| 10678146 | Not Issued | 030 | 10/06/2003 | METHOD AND APPARATUS FOR PROCESSING COMPOSITE MEMBER | YANAGITA, KAZUTAKA |
| 10644032 | Not Issued | 030 | 08/20/2003 | METHOD AND APPARATUS FOR SEPARATING SAMPLE | YANAGITA, KAZUTAKA |

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|---|---|---|---|---|---|
| 10639460 | Not Issued | 093 | 08/13/2003 | SAMPLE PROCESSING SYSTEM | YANAGITA, KAZUTAKA |
| 10602922 | Not Issued | 030 | 06/25/2003 | SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | YANAGITA, KAZUTAKA |
| 10330705 | Not Issued | 041 | 12/27/2002 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | YANAGITA, KAZUTAKA |
| 10318231 | Not Issued | 093 | 12/12/2002 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | YANAGITA, KAZUTAKA |
| 10314233 | Not Issued | 161 | 12/09/2002 | MEMBER SEPARATING APPARATUS AND PROCESSING APPARATUS | YANAGITA, KAZUTAKA |
| 10202022 | 6746559 | 150 | 07/25/2002 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | YANAGITA, KAZUTAKA |
| 10178746 | 6825099 | 150 | 06/25/2002 | METHOD AND APPARATUS FOR SEPARATING MEMBER | YANAGITA, KAZUTAKA |
| 10178359 | Not Issued | 094 | 06/25/2002 | METHOD AND APPARATUS FOR SEPARATING MEMBER | YANAGITA, KAZUTAKA |
| 10175201 | 6773534 | 150 | 06/20/2002 | SAMPLE PROCESSING APPARATUS AND METHOD | YANAGITA, KAZUTAKA |
| 10175004 | 6609553 | 150 | 06/20/2002 | SAMPLE PROCESSING APPARATUS AND METHOD | YANAGITA, KAZUTAKA |
| 10153608 | 6672358 | 150 | 05/24/2002 | SAMPLE PROCESSING SYSTEM | YANAGITA, KAZUTAKA |
| 10152830 | Not Issued | 095 | 05/23/2002 | PLATE MEMBER SEPARATING APPARATUS AND METHOD | YANAGITA, KAZUTAKA |
| 10152690 | Not Issued | 094 | 05/23/2002 | SEPARATING APPARATUS AND PROCESSING | YANAGITA, KAZUTAKA |

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|---|---|---|---|---|---|
| | | | | METHOD FOR PLATE MEMBER | |
| 10151527 | 6521078 | 150 | 05/20/2002 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | YANAGITA, KAZUTAKA |
| 10091304 | Not Issued | 161 | 03/06/2002 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | YANAGITA, KAZUTAKA |
| 10081068 | Not Issued | 041 | 02/21/2002 | COMPOSITE MEMBER AND SEPARATING METHOD THEREFOR, BONDED SUBSTRATE STACK AND SEPARATING METHOD THEREFOR, TRANSFER METHOD FOR TRANSFER LAYER, AND SOI SUBSTRATE MANUFACTURING METHOD | YANAGITA, KAZUTAKA |
| 10020807 | 6597039 | 150 | 12/18/2001 | COMPOSITE MEMBER, ITS SEPARATION METHOD, AND PREPARATION METHOD OF SEMICONDUCTOR SUBSTRATE BY UTILIZATION THEREOF | YANAGITA, KAZUTAKA |
| 09935591 | Not Issued | 161 | 08/24/2001 | METHOD AND APPARATUS FOR SEPARATING SAMPLE | YANAGITA, KAZUTAKA |
| 09931771 | Not Issued | 161 | 08/20/2001 | WAFER PROCESSING APPARATUS AND METHOD, WAFER CONVEY ROBOT, SEMICONDUCTOR SUBSTRATE FABRICATION METHOD, AND SEMICONDUCTOR FABRICATION APPARATUS | YANAGITA, KAZUTAKA |
| 09930137 | 6712288 | 150 | 08/16/2001 | METHOD AND APPARATUS FOR SEPARATING SAMPLE | YANAGITA, KAZUTAKA |
| 09910017 | 6653206 | 150 | 07/23/2001 | METHOD AND APPARATUS FOR PROCESSING COMPOSITE MEMBER | YANAGITA, KAZUTAKA |

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|---|---|---|---|---|---|
| 09730560 | 6653205 | 150 | 12/07/2000 | COMPOSITE MEMBER SEPARATING METHOD, THIN FILM MANUFACTURING METHOD, AND COMPOSITE MEMBER SEPARATING APPARATUS | YANAGITA, KAZUTAKA |
| 09721816 | 6475323 | 150 | 11/24/2000 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | YANAGITA, KAZUTAKA |
| 09664715 | 6767840 | 150 | 09/19/2000 | WAFER PROCESSING APPARATUS, WAFER PROCESSING METHOD, AND SEMICONDUCTOR SUBSTRATE FABRICATION METHOD | YANAGITA, KAZUTAKA |
| 09558657 | 6605518 | 150 | 04/26/2000 | METHOD OF SEPARATING COMPOSITE MEMBER AND PROCESS FOR PRODUCING THIN FILM | YANAGITA, KAZUTAKA |
| 09496130 | 6624047 | 150 | 02/01/2000 | SUBSTRATE AND METHOD OF MANUFACTURING THE SAME | YANAGITA, KAZUTAKA |
| 09495847 | 6609446 | 150 | 02/01/2000 | SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | YANAGITA, KAZUTAKA |
| 09495646 | 6426270 | 150 | 02/01/2000 | SUBSTRATE PROCESSING METHOD AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | YANAGITA, KAZUTAKA |
| 09494851 | 6376332 | 150 | 02/01/2000 | COMPOSITE MEMBER AND SEPARATING METHOD THEREFOR, BONDED SUBSTRATE STACK AND SEPARATING METHOD THEREFOR, TRANSFER METHOD FOR TRANSFER LAYER, AND SOI SUBSTRATE MANUFACTURING METHOD | YANAGITA, KAZUTAKA |
| 09434741 | Not Issued | 164 | 11/05/1999 | SAMPLE PROCESSING SYSTEM | YANAGITA , KAZUTAKA |

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|---|---|---|---|---|---|
| 09434740 | 6527031 | 150 | 11/05/1999 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | YANAGITA , KAZUTAKA |
| 09399643 | Not Issued | 161 | 09/20/1999 | SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | YANAGITA , KAZUTAKA |
| 09275305 | 6540861 | 150 | 03/24/1999 | MEMBER SEPARATING APPARATUS AND PROCESSING APPARATUS | YANAGITA , KAZUTAKA |
| 09211876 | 6436226 | 150 | 12/15/1998 | OBJECT SEPARATING APPARATUS AND METHOD, AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | YANAGITA , KAZUTAKA |
| 09211757 | 6418999 | 150 | 12/15/1998 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | YANAGITA , KAZUTAKA |
| 09211738 | 6380099 | 150 | 12/15/1998 | POROUS REGION REMOVING METHOD AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | YANAGITA , KAZUTAKA |
| 09211559 | 6127281 | 150 | 12/15/1998 | POROUS REGION REMOVING METHOD AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | YANAGITA , KAZUTAKA |
| 09096285 | 6427747 | 150 | 06/11/1998 | APPARATUS AND METHOD OF SEPARATING SAMPLE AND SUBSTRATE FABRICATION METHOD | YANAGITA , KAZUTAKA |
| 09047327 | 6382292 | 150 | 03/25/1998 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | YANAGITA , KAZUTAKA |
| 09025409 | 6199563 | 150 | 02/18/1998 | WAFER PROCESSING APPARATUS, WAFER | YANAGITA , KAZUTAKA |

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|---|---|---|---|---|---|
| | | | | PROCESSING METHOD, AND SEMICONDUCTOR SUBSTRATE FABRICATION METHOD | |
| 09015582 | 6391067 | 150 | 01/29/1998 | WAFER PROCESSING APPARATUS AND METHOD, WAFER CONVEY ROBOT, SEMICONDUCTOR SUBSTRATE FABRICATION METHOD, AND SEMICONDUCTOR FABRICATION APPARATUS | YANAGITA, KAZUTAKA |

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## Inventor Name Search Result

Your Search was:

Last Name = YANAGITA
First Name = KAZUTAKA

| Application# | Patent# | Status | Date Filed | Title | Inventor Name 5 |
|---|---|---|---|---|---|
| 09435285 | Not Issued | 161 | 11/05/1999 | SAMPLE PROCESSING SYSTEM | YANAGITA , KAZUTAKA |
| 09434741 | Not Issued | 164 | 11/05/1999 | SAMPLE PROCESSING SYSTEM | YANAGITA , KAZUTAKA |
| 09434663 | 6629539 | 150 | 11/05/1999 | SAMPLE PROCESSING SYSTEM | YANAGITA , KAZUTAKA |
| 09401775 | 6391743 | 150 | 09/22/1999 | METHOD AND APPARATUS FOR PRODUCING PHOTOELECTRIC CONVERSION DEVICE | YANAGITA , KAZUTAKA |
| 09359575 | 6427748 | 150 | 07/22/1999 | SAMPLE PROCESSING APPARATUS AND METHOD | YANAGITA , KAZUTAKA |

Inventor Search Completed: No Records to Display.

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**Last Name** YANAGITA **First Name** KAZUTAKA

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# Inventor Name Search Result

Your Search was:

Last Name = OHMI
First Name = KAZUAKI

| Application# | Patent# | Status | Date Filed | Title | Inventor Name 51 |
|---|---|---|---|---|---|
| 10963483 | Not Issued | 020 | 10/12/2004 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | OHMI, KAZUAKI |
| 10792695 | Not Issued | 041 | 03/05/2004 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | OHMI, KAZUAKI |
| 10678146 | Not Issued | 030 | 10/06/2003 | METHOD AND APPARATUS FOR PROCESSING COMPOSITE MEMBER | OHMI, KAZUAKI |
| 10639460 | Not Issued | 093 | 08/13/2003 | SAMPLE PROCESSING SYSTEM | OHMI, KAZUAKI |
| 10602922 | Not Issued | 030 | 06/25/2003 | SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | OHMI, KAZUAKI |
| 10402214 | Not Issued | 020 | 03/31/2003 | PROCESS FOR PRODUCING SINGLE CRYSTAL SILICON WAFERS | OHMI, KAZUAKI |
| 10330705 | Not Issued | 041 | 12/27/2002 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | OHMI, KAZUAKI |
| 10202022 | 6746559 | 150 | 07/25/2002 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | OHMI, KAZUAKI |
| 10153608 | 6672358 | 150 | 05/24/2002 | SAMPLE PROCESSING SYSTEM | OHMI, KAZUAKI |
| 10091304 | Not Issued | 161 | 03/06/2002 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | OHMI, KAZUAKI |
| 10081068 | Not Issued | 041 | 02/21/2002 | COMPOSITE MEMBER AND SEPARATING METHOD | OHMI, KAZUAKI |

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|---|---|---|---|---|---|
| | | | | THEREFOR, BONDED SUBSTRATE STACK AND SEPARATING METHOD THEREFOR, TRANSFER METHOD FOR TRANSFER LAYER, AND SOI SUBSTRATE MANUFACTURING METHOD | |
| 10020807 | 6597039 | 150 | 12/18/2001 | COMPOSITE MEMBER, ITS SEPARATION METHOD, AND PREPARATION METHOD OF SEMICONDUCTOR SUBSTRATE BY UTILIZATION THEREOF | OHMI, KAZUAKI |
| 09910017 | 6653206 | 150 | 07/23/2001 | METHOD AND APPARATUS FOR PROCESSING COMPOSITE MEMBER | OHMI, KAZUAKI |
| 09730560 | 6653205 | 150 | 12/07/2000 | COMPOSITE MEMBER SEPARATING METHOD, THIN FILM MANUFACTURING METHOD, AND COMPOSITE MEMBER SEPARATING APPARATUS | OHMI, KAZUAKI |
| 09721816 | 6475323 | 150 | 11/24/2000 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | OHMI, KAZUAKI |
| 09558657 | 6605518 | 150 | 04/26/2000 | METHOD OF SEPARATING COMPOSITE MEMBER AND PROCESS FOR PRODUCING THIN FILM | OHMI, KAZUAKI |
| 09534340 | 6468923 | 150 | 03/24/2000 | METHOD OF PRODUCING SEMICONDUCTOR MEMBER | OHMI, KAZUAKI |
| 09496130 | 6624047 | 150 | 02/01/2000 | SUBSTRATE AND METHOD OF MANUFACTURING THE SAME | OHMI, KAZUAKI |
| 09495847 | 6609446 | 150 | 02/01/2000 | SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | OHMI, KAZUAKI |
| 09495646 | 6426270 | 150 | 02/01/2000 | SUBSTRATE PROCESSING METHOD AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | OHMI, KAZUAKI |
| 09494851 | 6376332 | 150 | 02/01/2000 | COMPOSITE MEMBER AND SEPARATING METHOD THEREFOR, BONDED SUBSTRATE STACK AND SEPARATING METHOD THEREFOR, TRANSFER | OHMI, KAZUAKI |

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|---|---|---|---|---|---|
| | | | | METHOD FOR TRANSFER LAYER, AND SOI SUBSTRATE MANUFACTURING METHOD | |
| 09453539 | 6656271 | 150 | 12/03/1999 | METHOD OF MANUFACTURING SEMICONDUCTOR WAFER METHOD OF USING AND UTILIZING THE SAME | OHMI, KAZUAKI |
| 09435285 | Not Issued | 161 | 11/05/1999 | SAMPLE PROCESSING SYSTEM | OHMI , KAZUAKI |
| 09401775 | 6391743 | 150 | 09/22/1999 | METHOD AND APPARATUS FOR PRODUCING PHOTOELECTRIC CONVERSION DEVICE | OHMI , KAZUAKI |
| 09399643 | Not Issued | 161 | 09/20/1999 | SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | OHMI , KAZUAKI |
| 09250242 | 6342433 | 150 | 02/16/1999 | COMPOSITE MEMBER ITS SEPARATION METHOD AND PREPARATION METHOD OF SEMICONDUCTOR SUBSTRATE BY UTILIZATION THEREOF | OHMI , KAZUAKI |
| 09047338 | Not Issued | 161 | 03/25/1998 | SEMICONDUCTOR SUBSTRATE AND PROCESS FOR PRODUCING THE SAME USING A COMPOSITE MEMBER HAVING POROUS LAYERS AND VARYING THICKNESS AND POROSITY | OHMI , KAZUAKI |
| 09047327 | 6382292 | 150 | 03/25/1998 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | OHMI , KAZUAKI |
| 09045955 | 6140209 | 150 | 03/23/1998 | PROCESS FOR FORMING AN SOI SUBSTRATE | OHMI , KAZUAKI |
| 08675843 | 5776255 | 150 | 07/05/1996 | CHEMICAL VAPOR DEPOSITION APPARATUS | OHMI , KAZUAKI |
| 08646556 | 5723034 | 150 | 05/08/1996 | PROCESS FOR FORMING HYDROGENATED AMORPHOUS SILICON FILM | OHMI , KAZUAKI |
| 08476030 | 5723877 | 150 | 06/07/1995 | PHOTOELECTRIC CONVERSION APPARATUS | OHMI , KAZUAKI |
| 08337457 | Not Issued | 166 | 11/04/1994 | PROCESS FOR FORMING HYDROGENATED AMORPHOUS SILICON FILM | OHMI , KAZUAKI |
| 08257294 | 6025243 | 150 | 06/09/1994 | PROCESS FOR FORMING DEPOSITED FILM AND PROCESS FOR PREPARING SEMICONDUCTOR DEVICE | OHMI , KAZUAKI |

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|---|---|---|---|---|---|
| 08239570 | 5500102 | 150 | 05/09/1994 | METHOD OF FORMING DEPOSITED SEMICONDUCTOR FILM | OHMI , KAZUAKI |
| 08231066 | 5563092 | 250 | 04/22/1994 | METHOD OF PRODUCING A SUBSTRATE FOR AN AMORPHOUS SEMICONDUCTOR | OHMI , KAZUAKI |
| 08171431 | Not Issued | 166 | 12/22/1993 | CHEMICAL VAPOR DEPOSITION APPARATUS | OHMI , KAZUAKI |
| 08148415 | Not Issued | 161 | 11/08/1993 | PROCESS FOR FORMING DEPOSITED FILM AND PROCESS FOR PREPARING SEMICONDUCTOR DEVICE | OHMI , KAZUAKI |
| 08141723 | 6127692 | 150 | 10/26/1993 | PHOTOELECTRIC CONVERSION APPARATUS | OHMI , KAZUAKI |
| 08102980 | Not Issued | 166 | 07/28/1993 | PROCESS FOR FORMING AMORPHOUS SILICON HYDRIDE FILM | OHMI , KAZUAKI |
| 07975139 | Not Issued | 161 | 11/12/1992 | PROCESS FOR FORMING DEPOSITED FILM AND PROCESS FOR PREPARING SEMICONDUCTOR DEVICE | OHMI , KAZUAKI |
| 07765469 | Not Issued | 166 | 09/26/1991 | PROCESS FOR FORMING METAL DEPOSITED FILM CONTAINING ALUMINUM AS MAIN COMPONENT BY USE OF ALKYL ALUMINUM HYDRIDE | OHMI , KAZUAKI |
| 07667400 | Not Issued | 166 | 04/03/1991 | PHOTOELECTRIC CONVERSION APPARATUS | OHMI , KAZUAKI |
| 07588287 | Not Issued | 166 | 09/26/1990 | PROCESS FOR FORMING METAL DEPOSITED FILM CONTAINING ALUMINUM AS MAIN COMPONENT BY USE OF ALKYL ALUMINUM HYDRIDE | OHMI , KAZUAKI |
| 07588265 | Not Issued | 166 | 09/26/1990 | PROCESS FOR FORMING DEPOSITED FILM AND PROCESS FOR PREPARING SEMICONDUCTOR DEVICE | OHMI , KAZUAKI |
| 07587844 | 5134092 | 150 | 09/25/1990 | PROCESS FOR FORMING DEPOSITED FILM AND PROCESS FOR PRODUCING SEMICONDUCTOR DEVICE | OHMI , KAZUAKI |
| 07256472 | 4931692 | 150 | 10/12/1988 | LUMINESCING MEMBER, PROCESS FOR PREPARATION THEREOF, AND ELECTRO-LUMINESCENT DEVICE EMPLOYING SAME | OHMI , KAZUAKI |

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| 07179866 | Not Issued | 168 | 04/11/1988 | JOSEPHSON JUNCTION DEVICE AND METHOD OF PRODUCING THE SAME | OHMI , KAZUAKI |
| 07173637 | Not Issued | 161 | 03/25/1988 | SUBSTRATE-TREATING APPARATUS | OHMI , KAZUAKI |
| 06402700 | 4444862 | 150 | 07/28/1982 | ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MATERIALS HAVING LAYER OF ORGANIC METAL COMPOUND | OHMI , KAZUAKI |
| 06137191 | 4315980 | 150 | 04/04/1980 | ELECTROPHOTOGRAHIC MEMBER WITH METALLOLENE CONTAININE OVERLAYER | OHMI , KAZUAKI |

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**Last Name** OHMI **First Name** KAZUAKI

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# Inventor Name Search Result

Your Search was:

Last Name = OHMI
First Name = KAZUAKI

| Application# | Patent# | Status | Date Filed | Title | Inventor Name 5 |
|---|---|---|---|---|---|
| 09434741 | Not Issued | 164 | 11/05/1999 | SAMPLE PROCESSING SYSTEM | OHMI , KAZUAKI |
| 09434740 | 6527031 | 150 | 11/05/1999 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | OHMI , KAZUAKI |
| 09434663 | 6629539 | 150 | 11/05/1999 | SAMPLE PROCESSING SYSTEM | OHMI , KAZUAKI |
| 09401775 | 6391743 | 150 | 09/22/1999 | METHOD AND APPARATUS FOR PRODUCING PHOTOELECTRIC CONVERSION DEVICE | OHMI , KAZUAKI |
| 09250242 | 6342433 | 150 | 02/16/1999 | COMPOSITE MEMBER ITS SEPARATION METHOD AND PREPARATION METHOD OF SEMICONDUCTOR SUBSTRATE BY UTILIZATION THEREOF | OHMI , KAZUAKI |

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# Inventor Name Search Result

Your Search was:

Last Name = SAKAGUCHI
First Name = KIYOFUMI

| Application# | Patent# | Status | Date Filed | Title | Inventor Name 51 |
|---|---|---|---|---|---|
| 10678146 | Not Issued | 030 | 10/06/2003 | METHOD AND APPARATUS FOR PROCESSING COMPOSITE MEMBER | SAKAGUCHI, KIYOFUMI |
| 10669002 | 6818104 | 150 | 09/24/2003 | PROCESS FOR PRODUCING SEMICONDUCTOR MEMBER, PROCESS FOR PRODUCING SOLAR CELL, AND ANODIZING APPARATUS | SAKAGUCHI, KIYOFUMI |
| 10654022 | Not Issued | 071 | 09/04/2003 | SUBSTRATE AND MANUFACTURING METHOD THEREFOR | SAKAGUCHI, KIYOFUMI |
| 10654008 | Not Issued | 041 | 09/04/2003 | SUBSTRATE AND MANUFACTURING METHOD THEREFOR | SAKAGUCHI, KIYOFUMI |
| 10653950 | Not Issued | 041 | 09/04/2003 | SUBSTRATE AND MANUFACTURING METHOD THEREFOR | SAKAGUCHI, KIYOFUMI |
| 10653949 | Not Issued | 030 | 09/04/2003 | SUBSTRATE AND MANUFACTURING METHOD THEREFOR | SAKAGUCHI, KIYOFUMI |
| 10644032 | Not Issued | 030 | 08/20/2003 | METHOD AND APPARATUS FOR SEPARATING SAMPLE | SAKAGUCHI, KIYOFUMI |
| 10639460 | Not Issued | 093 | 08/13/2003 | SAMPLE PROCESSING SYSTEM | SAKAGUCHI, KIYOFUMI |
| 10619576 | Not Issued | 030 | 07/16/2003 | SUBSTRATE PROCESSING METHOD AND SUBSTRATE PROCESSING APPARATUS | SAKAGUCHI, KIYOFUMI |
| 10602922 | Not Issued | 030 | 06/25/2003 | SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF | SAKAGUCHI, KIYOFUMI |

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|---|---|---|---|---|---|
| | | | | MANUFACTURING SEMICONDUCTOR SUBSTRATE | |
| 10459044 | Not Issued | 030 | 06/11/2003 | ANODIZING METHOD AND APPARATUS AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI, KIYOFUMI |
| 10447156 | Not Issued | 071 | 05/29/2003 | DISPLAY APPARATUS AND PRODUCING METHOD THEREFOR | SAKAGUCHI, KIYOFUMI |
| 10338847 | Not Issued | 161 | 01/09/2003 | PROCESS FOR PRODUCING SEMICONDUCTOR ARTICLE | SAKAGUCHI, KIYOFUMI |
| 10178746 | 6825099 | 150 | 06/25/2002 | METHOD AND APPARATUS FOR SEPARATING MEMBER | SAKAGUCHI, KIYOFUMI |
| 10178361 | Not Issued | 041 | 06/25/2002 | SEMICONDUCTOR SUBSTRATE AND PROCESS FOR ITS PRODUCTION | SAKAGUCHI, KIYOFUMI |
| 10178359 | Not Issued | 094 | 06/25/2002 | METHOD AND APPARATUS FOR SEPARATING MEMBER | SAKAGUCHI, KIYOFUMI |
| 10175201 | 6773534 | 150 | 06/20/2002 | SAMPLE PROCESSING APPARATUS AND METHOD | SAKAGUCHI, KIYOFUMI |
| 10153608 | 6672358 | 150 | 05/24/2002 | SAMPLE PROCESSING SYSTEM | SAKAGUCHI, KIYOFUMI |
| 10152830 | Not Issued | 095 | 05/23/2002 | PLATE MEMBER SEPARATING APPARATUS AND METHOD | SAKAGUCHI, KIYOFUMI |
| 10152690 | Not Issued | 094 | 05/23/2002 | SEPARATING APPARATUS AND PROCESSING METHOD FOR PLATE MEMBER | SAKAGUCHI, KIYOFUMI |
| 10091304 | Not Issued | 161 | 03/06/2002 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | SAKAGUCHI, KIYOFUMI |
| 10085046 | Not Issued | 071 | 03/01/2002 | PROCESS FOR PRODUCTION OF SEMICONDUCTOR SUBSTRATE | SAKAGUCHI, KIYOFUMI |
| 10081068 | Not Issued | 041 | 02/21/2002 | COMPOSITE MEMBER | SAKAGUCHI, |

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|---|---|---|---|---|---|
| | | | | AND SEPARATING METHOD THEREFOR, BONDED SUBSTRATE STACK AND SEPARATING METHOD THEREFOR, TRANSFER METHOD FOR TRANSFER LAYER, AND SOI SUBSTRATE MANUFACTURING METHOD | KIYOFUMI |
| 10059171 | Not Issued | 094 | 01/31/2002 | METHOD OF MANUFACTURING A THIN-FILM SEMICONDUCTOR DEVICE USED FOR A DISPLAY REGION AND PERIPHERAL CIRCUIT REGION | SAKAGUCHI, KIYOFUMI |
| 10020807 | 6597039 | 150 | 12/18/2001 | COMPOSITE MEMBER, ITS SEPARATION METHOD, AND PREPARATION METHOD OF SEMICONDUCTOR SUBSTRATE BY UTILIZATION THEREOF | SAKAGUCHI, KIYOFUMI |
| 09935591 | Not Issued | 161 | 08/24/2001 | METHOD AND APPARATUS FOR SEPARATING SAMPLE | SAKAGUCHI, KIYOFUMI |
| 09930137 | 6712288 | 150 | 08/16/2001 | METHOD AND APPARATUS FOR SEPARATING SAMPLE | SAKAGUCHI, KIYOFUMI |
| 09910017 | 6653206 | 150 | 07/23/2001 | METHOD AND APPARATUS FOR PROCESSING COMPOSITE MEMBER | SAKAGUCHI, KIYOFUMI |
| 09769329 | 6602767 | 150 | 01/26/2001 | METHOD FOR TRANSFERRING POROUS LAYER, METHOD FOR MAKING SEMICONDUCTOR DEVICES, AND METHOD FOR MAKING SOLAR BATTERY | SAKAGUCHI, KIYOFUMI |
| 09764400 | Not Issued | 161 | 01/19/2001 | SEMICONDUCTOR DEVICE, AND METHOD FOR MANUFACTURING THE SAME | SAKAGUCHI, KIYOFUMI |
| 09749730 | Not Issued | 161 | 12/28/2000 | SEMICONDUCTOR | SAKAGUCHI, |

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|---|---|---|---|---|---|
| | | | | SUBSTRATE AND PROCESS FOR ITS PRODUCTION | KIYOFUMI |
| 09734667 | Not Issued | 168 | 12/13/2000 | METHOD FOR PRODUCING A SEMICONDUCTOR FILM | SAKAGUCHI, KIYOFUMI |
| 09730560 | 6653205 | 150 | 12/07/2000 | COMPOSITE MEMBER SEPARATING METHOD, THIN FILM MANUFACTURING METHOD, AND COMPOSITE MEMBER SEPARATING APPARATUS | SAKAGUCHI, KIYOFUMI |
| 09721816 | 6475323 | 150 | 11/24/2000 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | SAKAGUCHI, KIYOFUMI |
| 09706877 | 6569748 | 150 | 11/07/2000 | SUBSTRATE AND PRODUCTION METHOD THEREOF | SAKAGUCHI, KIYOFUMI |
| 09680376 | 6428620 | 150 | 10/05/2000 | SUBSTRATE PROCESSING METHOD AND APPARATUS AND SOI SUBSTRATE | SAKAGUCHI, KIYOFUMI |
| 09664715 | 6767840 | 150 | 09/19/2000 | WAFER PROCESSING APPARATUS, WAFER PROCESSING METHOD, AND SEMICONDUCTOR SUBSTRATE FABRICATION METHOD | SAKAGUCHI, KIYOFUMI |
| 09638398 | 6756289 | 150 | 08/15/2000 | METHOD OF PRODUCING SEMICONDUCTOR MEMBER AND METHOD OF PRODUCING SOLAR CELL | SAKAGUCHI, KIYOFUMI |
| 09634542 | 6534382 | 150 | 08/08/2000 | PROCESS FOR PRODUCING SEMICONDUCTOR ARTICLE | SAKAGUCHI, KIYOFUMI |
| 09614548 | 6452091 | 150 | 07/12/2000 | METHOD OF PRODUCING THIN-FILM SINGLE-CRYSTAL DEVICE, SOLAR CELL MODULE AND METHOD OF PRODUCING THE SAME | SAKAGUCHI, KIYOFUMI |
| 09592559 | 6448155 | 150 | 06/12/2000 | PRODUCTION METHOD OF | SAKAGUCHI, |

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|---|---|---|---|---|---|
| | | | | SEMICONDUCTOR BASE MATERIAL AND PRODUCTION METHOD OF SOLAR CELL | KIYOFUMI |
| 09586887 | 6664169 | 150 | 06/05/2000 | PROCESS FOR PRODUCING SEMICONDUCTOR MEMBER, PROCESS FOR PRODUCING SOLAR CELL, AND ANODIZING APPARATUS | SAKAGUCHI, KIYOFUMI |
| 09572940 | 6534336 | 150 | 05/18/2000 | PRODUCTION METHOD OF PHOTOELECTRIC CONVERSION DEVICE, AND PHOTOELECTRIC CONVERSION DEVICE PRODUCED BY THE METHOD | SAKAGUCHI, KIYOFUMI |
| 09558657 | 6605518 | 150 | 04/26/2000 | METHOD OF SEPARATING COMPOSITE MEMBER AND PROCESS FOR PRODUCING THIN FILM | SAKAGUCHI, KIYOFUMI |
| 09534340 | 6468923 | 150 | 03/24/2000 | METHOD OF PRODUCING SEMICONDUCTOR MEMBER | SAKAGUCHI, KIYOFUMI |
| 09532071 | 6417069 | 150 | 03/21/2000 | SUBSTRATE PROCESSING METHOD AND MANUFACTURING METHOD, AND ANODIZING APPARATUS | SAKAGUCHI, KIYOFUMI |
| 09496130 | 6624047 | 150 | 02/01/2000 | SUBSTRATE AND METHOD OF MANUFACTURING THE SAME | SAKAGUCHI, KIYOFUMI |
| 09495847 | 6609446 | 150 | 02/01/2000 | SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | SAKAGUCHI, KIYOFUMI |
| 09495646 | 6426270 | 150 | 02/01/2000 | SUBSTRATE PROCESSING METHOD AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | SAKAGUCHI, KIYOFUMI |
| 09494851 | 6376332 | 150 | 02/01/2000 | COMPOSITE MEMBER AND SEPARATING METHOD THEREFOR, | SAKAGUCHI, KIYOFUMI |

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|---|---|---|---|---|---|
| | | | | BONDED SUBSTRATE STACK AND SEPARATING METHOD THEREFOR, TRANSFER METHOD FOR TRANSFER LAYER, AND SOI SUBSTRATE MANUFACTURING METHOD | |
| 09453539 | 6656271 | 150 | 12/03/1999 | METHOD OF MANUFACTURING SEMICONDUCTOR WAFER METHOD OF USING AND UTILIZING THE SAME | SAKAGUCHI, KIYOFUMI |

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**Last Name** SAKAGUCHI **First Name** KIYOFUMI

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Last Name = SAKAGUCHI
First Name = KIYOFUMI

| Application# | Patent# | Status | Date Filed | Title | Inventor Name 51 |
|---|---|---|---|---|---|
| 10963483 | Not Issued | 020 | 10/12/2004 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI, KIYOFUMI |
| 10944864 | Not Issued | 020 | 09/21/2004 | METHOD AND APPARATUS FOR SEPARATING MEMBER | SAKAGUCHI, KIYOFUMI |
| 10857881 | Not Issued | 030 | 06/02/2004 | SEMICONDUCTOR SUBSTRATE, SEMICONDUCTOR DEVICE, AND METHOD OF MANUFACTURING THE SAME | SAKAGUCHI, KIYOFUMI |
| 10838269 | Not Issued | 030 | 05/05/2004 | MEMBER AND MEMBER MANUFACTURING METHOD | SAKAGUCHI, KIYOFUMI |
| 10834932 | Not Issued | 030 | 04/30/2004 | SEPARATING APPARATUS AND PROCESSING METHOD FOR PLATE MEMBER | SAKAGUCHI, KIYOFUMI |
| 10602922 | Not Issued | 030 | 06/25/2003 | SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | SAKAGUCHI, KIYOFUMI |
| 10459044 | Not Issued | 030 | 06/11/2003 | ANODIZING METHOD AND APPARATUS AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI, KIYOFUMI |

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| 10330705 | Not Issued | 041 | 12/27/2002 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI, KIYOFUMI |
| 10327147 | 6800871 | 150 | 12/24/2002 | DISPLAY DEVICE AND PROCESS OF PRODUCING THE SAME | SAKAGUCHI, KIYOFUMI |
| 10318231 | Not Issued | 093 | 12/12/2002 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI, KIYOFUMI |
| 10314233 | Not Issued | 161 | 12/09/2002 | MEMBER SEPARATING APPARATUS AND PROCESSING APPARATUS | SAKAGUCHI, KIYOFUMI |
| 10202022 | 6746559 | 150 | 07/25/2002 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | SAKAGUCHI, KIYOFUMI |
| 10178361 | Not Issued | 041 | 06/25/2002 | SEMICONDUCTOR SUBSTRATE AND PROCESS FOR ITS PRODUCTION | SAKAGUCHI, KIYOFUMI |
| 10178359 | Not Issued | 094 | 06/25/2002 | METHOD AND APPARATUS FOR SEPARATING MEMBER | SAKAGUCHI, KIYOFUMI |
| 10175004 | 6609553 | 150 | 06/20/2002 | SAMPLE PROCESSING APPARATUS AND METHOD | SAKAGUCHI, KIYOFUMI |
| 10153608 | 6672358 | 150 | 05/24/2002 | SAMPLE PROCESSING SYSTEM | SAKAGUCHI, KIYOFUMI |
| 10152830 | Not Issued | 095 | 05/23/2002 | PLATE MEMBER SEPARATING APPARATUS AND METHOD | SAKAGUCHI, KIYOFUMI |
| 10152690 | Not Issued | 094 | 05/23/2002 | SEPARATING APPARATUS AND PROCESSING METHOD FOR PLATE MEMBER | SAKAGUCHI, KIYOFUMI |
| 10151527 | 6521078 | 150 | 05/20/2002 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING | SAKAGUCHI, KIYOFUMI |

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|---|---|---|---|---|---|
| | | | | METHOD | |
| 10059144 | Not Issued | 061 | 01/31/2002 | THIN-FILM SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME | SAKAGUCHI, KIYOFUMI |
| 10059116 | 6677183 | 150 | 01/31/2002 | A METHOD OF SEPARATION OF SEMICONDUCTOR DEVICE | SAKAGUCHI, KIYOFUMI |
| 09978590 | Not Issued | 161 | 10/18/2001 | SEMICONDUCTOR SUBSTRATE, METHOD OF MANUFACTURING THE SAME, AND BONDED SUBSTRATE STACK SURFACE SHAPE MEASURING METHOD | SAKAGUCHI, KIYOFUMI |
| 09933711 | Not Issued | 168 | 08/22/2001 | FABRICATION PROCESS OF SEMICONDUCTOR SUBSTRATE | SAKAGUCHI, KIYOFUMI |
| 09931771 | Not Issued | 161 | 08/20/2001 | WAFER PROCESSING APPARATUS AND METHOD, WAFER CONVEY ROBOT, SEMICONDUCTOR SUBSTRATE FABRICATION METHOD, AND SEMICONDUCTOR FABRICATION APPARATUS | SAKAGUCHI, KIYOFUMI |
| 09920658 | 6429095 | 150 | 08/03/2001 | SEMICONDUCTOR ARTICLE AND METHOD OF MANUFACTURING THE SAME | SAKAGUCHI, KIYOFUMI |
| 09706877 | 6569748 | 150 | 11/07/2000 | SUBSTRATE AND PRODUCTION METHOD THEREOF | SAKAGUCHI, KIYOFUMI |
| 09680376 | 6428620 | 150 | 10/05/2000 | SUBSTRATE PROCESSING METHOD AND APPARATUS AND SOI SUBSTRATE | SAKAGUCHI, KIYOFUMI |
| 09434741 | Not Issued | 164 | 11/05/1999 | SAMPLE PROCESSING SYSTEM | SAKAGUCHI , KIYOFUMI |
| 09401775 | 6391743 | 150 | 09/22/1999 | METHOD AND APPARATUS FOR PRODUCING PHOTOELECTRIC CONVERSION DEVICE | SAKAGUCHI , KIYOFUMI |

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|---|---|---|---|---|---|
| 09399643 | Not Issued | 161 | 09/20/1999 | SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI , KIYOFUMI |
| 09347260 | 6350703 | 150 | 07/06/1999 | SEMICONDUCTOR SUBSTRATE AND PRODUCTION METHOD THEREOF | SAKAGUCHI , KIYOFUMI |
| 09312843 | 6613678 | 150 | 05/17/1999 | PROCESS FOR MANUFACTURING A SEMICONDUCTOR SUBSTRATE AS WELL AS A SEMICONDUCTOR THIN FILM, AND MULTILAYER STRUCTURE | SAKAGUCHI , KIYOFUMI |
| 09310954 | 6331208 | 150 | 05/13/1999 | PROCESS FOR PRODUCING SOLAR CELL, PROCESS FOR PRODUCING THIN-FILM SEMICONDUCTOR, PROCESS FOR SEPARATING THIN-FILM SEMICONDUCTOR, AND PROCESS FOR FORMING SEMICONDUCTOR | SAKAGUCHI , KIYOFUMI |
| 09251668 | Not Issued | 168 | 02/17/1999 | ANODIZING METHOD AND APPARATUS AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI , KIYOFUMI |
| 09250242 | 6342433 | 150 | 02/16/1999 | COMPOSITE MEMBER ITS SEPARATION METHOD AND PREPARATION METHOD OF SEMICONDUCTOR SUBSTRATE BY UTILIZATION THEREOF | SAKAGUCHI , KIYOFUMI |
| 09211876 | 6436226 | 150 | 12/15/1998 | OBJECT SEPARATING APPARATUS AND METHOD, AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | SAKAGUCHI , KIYOFUMI |
| 09211757 | 6418999 | 150 | 12/15/1998 | SAMPLE SEPARATING APPARATUS AND METHOD, AND | SAKAGUCHI , KIYOFUMI |

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|---|---|---|---|---|---|
| | | | | SUBSTRATE MANUFACTURING METHOD | |
| 09211738 | 6380099 | 150 | 12/15/1998 | POROUS REGION REMOVING METHOD AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI , KIYOFUMI |
| 09211570 | 6200878 | 150 | 12/15/1998 | SUBSTRATE PROCESSING METHOD | SAKAGUCHI , KIYOFUMI |
| 09211559 | 6127281 | 150 | 12/15/1998 | POROUS REGION REMOVING METHOD AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI , KIYOFUMI |
| 09047327 | 6382292 | 150 | 03/25/1998 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | SAKAGUCHI , KIYOFUMI |
| 09046433 | 6221738 | 150 | 03/24/1998 | SUBSTRATE AND PRODUCTION METHOD THEREOF | SAKAGUCHI , KIYOFUMI |
| 08392685 | 5466631 | 150 | 02/23/1995 | METHOD FOR PRODUCING SEMICONDUCTOR ARTICLES | SAKAGUCHI , KIYOFUMI |
| 08369325 | 5492859 | 150 | 01/06/1995 | METHOD FOR PRODUCING SEMICONDUCTOR DEVICE SUBSTRATE BY BONDING A POROUS LAYER AND AN AMORPHOUS LAYER | SAKAGUCHI , KIYOFUMI |
| 08355117 | Not Issued | 166 | 12/13/1994 | SEMICONDUCTOR MEMBER, AND PROCESS FOR PREPARING SAME AND SEMICONDUCTOR DEVICE FORMED BY USE OF SAME | SAKAGUCHI , KIYOFUMI |
| 08301263 | 5439843 | 150 | 09/06/1994 | METHOD FOR PREPARING A SEMICONDUCTOR SUBSTRATE USING POROUS SILICON | SAKAGUCHI , KIYOFUMI |
| 08242047 | 5530266 | 150 | 05/13/1994 | LIQUID CRYSTAL IMAGE DISPLAY UNIT AND METHOD FOR | SAKAGUCHI , KIYOFUMI |

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|---|---|---|---|---|---|
| | | | | FABRICATING SEMICONDUCTOR OPTICAL MEMBER | |
| 08191767 | Not Issued | 166 | 02/04/1994 | SEMICONDUCTOR MEMBER, AND PROCESS FOR PREPARING SAME AND SEMICONDUCTOR DEVICE FORMED BY USE OF SAME | SAKAGUCHI , KIYOFUMI |
| 08148341 | 5458755 | 150 | 11/08/1993 | ANODIZATION APPARATUS WITH SUPPORTING DEVICE FOR SUBSTRATE TO BE TREATED | SAKAGUCHI , KIYOFUMI |
| 08136274 | Not Issued | 166 | 10/15/1993 | SEMICONDUCTOR DEVICE SUBSTRATE AND PROCESS FOR PREPARING THE SAME | SAKAGUCHI , KIYOFUMI |
| 08127113 | 5374581 | 150 | 09/27/1993 | METHOD FOR PREPARING SEMICONDUCTOR MEMBER | SAKAGUCHI , KIYOFUMI |

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Last Name = SAKAGUCHI
First Name = KIYOFUMI

| Application# | Patent# | Status | Date Filed | Title | Inventor Name 51 |
|---|---|---|---|---|---|
| 09434741 | Not Issued | 164 | 11/05/1999 | SAMPLE PROCESSING SYSTEM | SAKAGUCHI , KIYOFUMI |
| 09401775 | 6391743 | 150 | 09/22/1999 | METHOD AND APPARATUS FOR PRODUCING PHOTOELECTRIC CONVERSION DEVICE | SAKAGUCHI , KIYOFUMI |
| 09399643 | Not Issued | 161 | 09/20/1999 | SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI , KIYOFUMI |
| 09347260 | 6350703 | 150 | 07/06/1999 | SEMICONDUCTOR SUBSTRATE AND PRODUCTION METHOD THEREOF | SAKAGUCHI , KIYOFUMI |
| 09312843 | 6613678 | 150 | 05/17/1999 | PROCESS FOR MANUFACTURING A SEMICONDUCTOR SUBSTRATE AS WELL AS A SEMICONDUCTOR THIN FILM, AND MULTILAYER STRUCTURE | SAKAGUCHI , KIYOFUMI |
| 09310954 | 6331208 | 150 | 05/13/1999 | PROCESS FOR PRODUCING SOLAR CELL, PROCESS FOR PRODUCING THIN-FILM SEMICONDUCTOR, PROCESS FOR SEPARATING THIN-FILM SEMICONDUCTOR, AND PROCESS FOR FORMING SEMICONDUCTOR | SAKAGUCHI , KIYOFUMI |
| 09251668 | Not Issued | 168 | 02/17/1999 | ANODIZING METHOD AND APPARATUS AND SEMICONDUCTOR | SAKAGUCHI , KIYOFUMI |

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| | | | | SUBSTRATE MANUFACTURING METHOD | |
| 09250242 | 6342433 | 150 | 02/16/1999 | COMPOSITE MEMBER ITS SEPARATION METHOD AND PREPARATION METHOD OF SEMICONDUCTOR SUBSTRATE BY UTILIZATION THEREOF | SAKAGUCHI , KIYOFUMI |
| 09211876 | 6436226 | 150 | 12/15/1998 | OBJECT SEPARATING APPARATUS AND METHOD, AND METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE | SAKAGUCHI , KIYOFUMI |
| 09211757 | 6418999 | 150 | 12/15/1998 | SAMPLE SEPARATING APPARATUS AND METHOD, AND SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI , KIYOFUMI |
| 09211738 | 6380099 | 150 | 12/15/1998 | POROUS REGION REMOVING METHOD AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI , KIYOFUMI |
| 09211570 | 6200878 | 150 | 12/15/1998 | SUBSTRATE PROCESSING METHOD | SAKAGUCHI , KIYOFUMI |
| 09211559 | 6127281 | 150 | 12/15/1998 | POROUS REGION REMOVING METHOD AND SEMICONDUCTOR SUBSTRATE MANUFACTURING METHOD | SAKAGUCHI , KIYOFUMI |
| 09161775 | Not Issued | 161 | 09/29/1998 | PROCESS FOR PRODUCTION OF SEMICONDUCTOR SUBSTRATE | SAKAGUCHI , KIYOFUMI |
| 09161774 | Not Issued | 030 | 09/29/1998 | PROCESS FOR PRODUCTION OF SEMICONDUCTOR SUBSTRATE | SAKAGUCHI , KIYOFUMI |
| 09118872 | 6121117 | 150 | 07/20/1998 | PROCESS FOR PRODUCTING SEMICONDUCTOR SUBSTRATE BY HEAT | SAKAGUCHI , KIYOFUMI |

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| | | | | TREATING | |
| 09096285 | 6427747 | 150 | 06/11/1998 | APPARATUS AND METHOD OF SEPARATING SAMPLE AND SUBSTRATE FABRICATION METHOD | SAKAGUCHI , KIYOFUMI |
| 09047338 | Not Issued | 161 | 03/25/1998 | SEMICONDUCTOR SUBSTRATE AND PROCESS FOR PRODUCING THE SAME USING A COMPOSITE MEMBER HAVING POROUS LAYERS AND VARYING THICKNESS AND POROSITY | SAKAGUCHI , KIYOFUMI |
| 09047327 | 6382292 | 150 | 03/25/1998 | METHOD AND APPARATUS FOR SEPARATING COMPOSITE MEMBER USING FLUID | SAKAGUCHI , KIYOFUMI |
| 09046433 | 6221738 | 150 | 03/24/1998 | SUBSTRATE AND PRODUCTION METHOD THEREOF | SAKAGUCHI , KIYOFUMI |
| 09015809 | 6337030 | 150 | 01/29/1998 | WAFER PROCESSING APPARATUS, WAFER PROCESSING METHOD, AND SOI WAFER FABRICATION METHOD | SAKAGUCHI , KIYOFUMI |
| 09015582 | 6391067 | 150 | 01/29/1998 | WAFER PROCESSING APPARATUS AND METHOD, WAFER CONVEY ROBOT, SEMICONDUCTOR SUBSTRATE FABRICATION METHOD, AND SEMICONDUCTOR FABRICATION APPARATUS | SAKAGUCHI , KIYOFUMI |
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| Application# | Patent# | Status | Date Filed | Title | Inventor Name 12 |
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| Application# | Patent# | Status | Date Filed | Title | Inventor Name 6 |
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